

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Shoji MIYAZAKI et al.

Attn: BOX PCT

Serial No. NEW

Docket No. 2001-0989A

Filed July 13, 2001

BIOSENSOR, THIN FILM ELECTRODE
FORMING METHOD, QUANTIFICATION
APPARATUS, AND QUANTIFICATION
METHOD

[Corresponding to PCT/JP00/08012

Filed November 14, 2000]

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PRELIMINARY AMENDMENT

Assistant Commissioner for Patents,
Washington, DC 20231

Sir:

Prior to examination of the above-referenced U.S. patent application please amend the application as follows:

IN THE SPECIFICATION

Please amend the specification as follows:

Please replace the paragraph beginning at page 15, line 21, to line 25, with the following rewritten paragraph:

According to claim 18 of the present invention, in the biosensor as defined in any of Claims 1 to 17, at least one or all of the first slits, the second slits, the third slits, and the fourth slits are formed by processing the electrical conductive layer by a laser.